



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Mao-Yi CHANG et al. Confirmation No: 1409
Appl. No. : 10/635,489
Filed : August 7, 2003
Title : METHOD FOR TRANSFORMING AN AMORPHOUS
SILICON LAYER INTO A POLYSILICON LAYER

TC/A.U. : 2818
Examiner : D. Vu

Docket No.: : CHAN3214/REF
Customer No: : 23364

AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of September 12, 2005, in connection with the above-identified application. This response is timely filed.

Please amend the application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.